



LIST OF PUBLICATIONS
CITED BY APPLICANT

Attorney Docket No.

SEL 125

Serial No.

09/255,605

Applicant

Shunpei YAMAZAKI et al

Filing Date

February 22, 1999

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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	Technology Center 2600		
				CLASS	SUB- CLASS	FILING DATE
JLC	6,087,679	07/11/00	Yamazaki et al	257	65	07/22/98
	6,140,667	10/31/00	Yamazaki et al	257	59	02/20/98
	6,160,271	12/12/00	Yamazaki et al	257	59	02/01/00
	6,307,214	10/23/01	Ohtani et al	257	59	05/27/98

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
JLC	JP 10-294280	11/04/98	Semiconductor Energy Lab			02/09/98
	JP 11-345767	12/14/99	Semiconductor Energy Lab			05/16/98
	JP 11-354442	12/24/99	Semiconductor Energy Lab			05/15/98

OTHER PUBLICATIONS

(Including Author, Title, Date, Pertinent Pages)

JLC	(1)	U.S. Patent Application No. 09/244,760 (pending) to Yamazaki et al filed February 5, 1999, including original specification, claims, abstract, drawings, PTO filing receipt and pending claims.
JLC	(2)	U.S. Patent Application No. 09/385,019 (pending) to Yamazaki et al filed August 30, 1999, including original specification, claims, abstract, drawings, PTO filing receipt and pending claims.
JLC	(3)	English abstract re Japanese Patent Application No. JP 10-294280, published November 4, 1998.
JLC	(4)	English abstract re Japanese Patent Application No. JP 11-345767, published December 14, 1999.
JLC	(5)	English abstract re Japanese Patent Application No. JP 11-354442, published December 24, 1999.

EXAMINER:

Vincent E. Kovalick

DATE CONSIDERED:

10/20/02

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.